Application No. Not Yet Assigned Amendment dated April 26, 2006 First Preliminary Amendment

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AMENDMENTS TO THE CLAIMS

This listing of claims will replace all prior versions and listings of claims in the application:

1. (Original) A composition for removing a photoresist comprising at least one compound (A) selected from a group consisting of a compound represented by the following general formula (I), a compound represented by the following general formula (III), and a compound represented by the following general formula (IV):

$$X^{3}-R^{3}$$
 0
| ||
 $X^{1}-R^{1}-N-C-R^{2}-X^{2}$ (1)

$$X^{3}-R^{3} = 0$$
| || || (11)
 $X^{1}-R^{1}-N-C-0-R^{2}-X^{2}$

$$X^3 - R^3 O$$
 $O R^3 - X^3$
 $| | | | | | | | (111)$
 $X^1 - R^1 - N - C - R^4 - C - N - R^1 - X^1$

wherein formulas (I) to (IV), R^1 and R^3 each independently represent a direct bond, or a linear or branched divalent hydrocarbon group having 1 to 5 carbon atoms, R^2 represents a linear or branched divalent hydrocarbon group having 1 to 5 carbon atoms, X^1 , X^2 , and X^3 each independently represent a hydrogen atom, an OH group, or

an alkyl group having 1 to 5 carbon atoms, and at least one of X^1 , X^2 , and X^3 in each of the formulas (I) to (IV) is an OH group; wherein formulas (III) and (IV), the plurality of R^1 s, R^2 s, and R^3 s, and the plurality of X^1 s, X^2 s, and X^3 s are the same or different; wherein formula (III), R^4 represents a direct bond, or a linear or branched divalent hydrocarbon group having 1 to 5 carbon atoms; and wherein formula (IV), R^5 represents a divalent organic group.

- 2. (Original) The composition according to claim 1, wherein the compound (A) is at least one compound selected from a group consisting of reaction products of ethylene carbonate and primary or secondary organic amines, reaction products of propylene carbonate and primary or secondary organic amines, reaction products of γ -butyrolactone and primary or secondary organic amines, reaction products of 1,3-dihydroxy-2-propanone and primary or secondary organic amines, and dehydration condensation reaction products of mono- or dicarboxylic acids and primary or secondary organic amines.
- 3. (Original) The composition according to claim 2, wherein the compound (A) is at least one compound selected from a group consisting of bis(2-hydroxyethyl)carbamate, bis(2-hydroxypropyl)carbamate, N-(2-hydroxyethyl)-C-(3-hydroxypropyl)amide, N,N'-bis(2-hydroxyethyl)oxamide, N,N'-bis(2-hydroxyethyl)malonamide, (2-hydroxyethyl)acetamide, N-(2-hydroxyethyl)-N-methyl-C-(3-hydroxypropyl)amide, and N,N-bis(2-hydroxyethyl)-C-(3-hydroxypropyl)amide.
- 4. (Original) The composition according to claim 1, wherein at least X^1 and X^2 of the compound (A) are OH groups.
- 5. (Currently Amended) The composition according to any one of claims 1 to 4 claim 1, further comprising an organic amine (B).
- 6. (Currently Amended) The composition according to any one of claims 1 to 5claim 1, further comprising a water-soluble organic solvent (C).

7. (Currently Amended) The composition according to any one of claims 1 to 6claim 1, further comprising water (D).

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- 8. (Currently Amended) The composition according to any one of claims 1 to 7claim 1, wherein the amount of the compound (A) is from 5 to 100 wt%.
 - 9. (Original) A method for removing a photoresist comprising the steps of:
 - (1) preparing the composition according to any one of claims 1 to 8; and
 - (2) immersing an object having a photoresist to be removed in the composition.
- 10. (Original) The method according to claim 9, further comprising the step of rinsing the object with water after the step (2).
- 11. (Currently Amended) The method according to claim 9-or-10, wherein the photoresist is a positive-type photoresist.